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# Contents

<b>1</b>	<b>Introduction</b> .....	1
<b>2</b>	<b>Ring Resonators: Theory and Modeling</b> .....	3
2.1	Single Ring Resonators .....	3
2.1.1	Ring Structure .....	3
2.1.2	Racetrack-Shaped Resonators .....	16
2.2	Double Ring Resonators .....	17
2.2.1	Serially Coupled Double Ring Resonator .....	18
2.2.2	Parallel Coupled Double Ring Resonator .....	21
2.3	Multiple Coupled Resonators .....	25
2.3.1	Serially Coupled Ring Resonators .....	26
2.3.2	Parallel Coupled Ring Resonators .....	34
<b>3</b>	<b>Materials, Fabrication, and Characterization Methods</b> .....	41
3.1	Wafer Bonding .....	42
3.1.1	Bonding with Intermediate Layer .....	42
3.1.2	Bonding Without Intermediate Layer .....	43
3.1.3	Benzocyclobutene Wafer Bonding .....	44
3.2	Dry Etching .....	46
3.3	Si-Based Materials .....	47
3.3.1	Ring Resonators Based on Si-SiO <sub>2</sub> .....	47
3.3.2	Ring Resonators Based on Ta <sub>2</sub> O <sub>5</sub> -SiO <sub>2</sub> .....	52
3.3.3	Ring Resonators Based on SiN, SiON, and Si <sub>3</sub> N <sub>4</sub> .....	54
3.3.4	Ring Resonators Based on SiO <sub>2</sub> -GeO <sub>2</sub> .....	57
3.4	III-V Materials .....	57
3.4.1	The Quaternary Semiconductor Compound GaInAsP .....	57
3.4.2	The Semiconductor Compound AlGaAs .....	59
3.4.3	Lateral Coupling in GaInAsP/InP .....	60
3.4.4	Vertical Coupling in GaInAsP/InP .....	67

3.4.5	Lateral Coupling in AlGaAs/GaAs . . . . .	71
3.4.6	Vertical Coupling in AlGaAs/GaAs . . . . .	73
3.4.7	Implementation of Gain in Ring Resonators . . . . .	74
3.5	Polymers . . . . .	83
3.5.1	Conventional Fabrication Techniques . . . . .	83
3.5.2	Replication and Nanoimprinting . . . . .	89
3.6	Temperature Insensitivity . . . . .	94
3.7	Polarization Independence . . . . .	96
3.8	Characterization Methods . . . . .	99
3.8.1	Conventional Characterization . . . . .	100
3.8.2	Optical Low Coherence Reflectometry . . . . .	103
3.8.3	Evanescent Field Measurement Methods . . . . .	106
<b>4</b>	<b>Building Blocks of Ring Resonator Devices . . . . .</b>	<b>111</b>
4.1	Couplers . . . . .	112
4.1.1	Directional Couplers . . . . .	112
4.1.2	Multimode Interference Couplers . . . . .	114
4.1.3	Y-Couplers . . . . .	116
4.2	Bends . . . . .	118
4.3	Spot Size Converters for Light In- and Outcoupling . . . . .	123
<b>5</b>	<b>Devices . . . . .</b>	<b>125</b>
5.1	Filters . . . . .	126
5.1.1	Passive Devices . . . . .	126
5.1.2	Devices with Gain Section . . . . .	143
5.2	Tunability Methods . . . . .	150
5.2.1	Wavelength Tuning . . . . .	151
5.2.2	Center Wavelength Trimming . . . . .	159
5.2.3	Tunable Couplers in Ring Resonators . . . . .	164
5.3	Dispersion Compensators . . . . .	165
5.4	Mach-Zehnder Interferometers Combined with Ring Resonators . . . . .	169
5.5	Modulators . . . . .	173
5.6	Lasers . . . . .	178
5.6.1	All Active Lasers . . . . .	179
5.6.2	Devices with Gain Section . . . . .	187
5.6.3	Passive Ring Resonator Coupled Lasers . . . . .	191
5.7	Wavelength Converters . . . . .	197
5.8	Optical Signal Processing . . . . .	202
5.8.1	Logic Gates . . . . .	203
5.8.2	Switching . . . . .	206
5.9	Sensors . . . . .	209

<b>6</b>	<b>Whispering Gallery Mode Devices</b> .....	215
6.1	Whispering Gallery Modes .....	215
6.2	WGM Filters .....	216
6.3	WGM Lasers .....	219
<b>7</b>	<b>Outlook</b> .....	231
	<b>References</b> .....	233
	<b>Index</b> .....	255





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